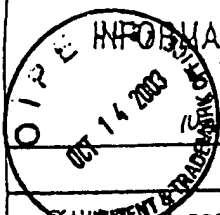


Form PTO-1449



# INFORMATION DISCLOSURE CITATION IN AN APPLICATION

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Application Number

TSMC-00-268

10/615,744

Applicant

Yi-Lung Cheng et al.

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## U. S. PATENT DOCUMENTS

EXAMINER'S INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
ME	6077764	6/20/00	Sugiarto et al.	438	597	4/21/97
ME	6221793	4/24/01	Ngo et al.	438	788	3/1/00
ME	5827785	10/27/98	Bhan et al.	438	784	10/24/96
ME	5429995	7/4/95	Nishigama et al.	437	238	7/16/93
ME	6242338	6/5/01	Liu et al.	438	622	10/22/99
ME	6136680	10/24/00	Lai et al.	438	597	1/21/00
ME	6103601	8/15/00	Lee et al.	438	513	6/10/99

## FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
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## OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)


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